

Special Issue

Micro/Nano Photonic Devices and Systems

Message from the Guest Editors

This Special Issue seeks reviews, regular research papers, and short communications on the advances in the science and technologies that enable the miniaturization of photonic devices and systems. Areas of interest include, but are not limited to, novel fabrication techniques, materials synthesis, optical properties of nano and micro structures and materials, novel device structures or concepts, new insights into device/system design, modeling, and characterization, device/system actuation and tuning, packaging and integration, and the innovative use of miniaturized photonic devices and systems in applications including, but are not limited to, sensing, display and imaging, energy conversion, optofluidics, data storage, communication, microscopy, spectroscopy, optical MEMS, and quantum information processing.

Prof. Dr. Jaeyoun (Jay) Kim

Guest Editors

Prof. Dr. Pei-Cheng Ku

EECS Department, University of Michigan, 1301 Beal Ave, Ann Arbor, MI 48109, USA

Prof. Dr. Jaeyoun Kim

Department of Electrical & Computer Engineering, Iowa State University, Ames, IA 50011, USA

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Micromachines
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
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Editor-in-Chief

Prof. Dr. Ai-Qun Liu

1. Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China
2. School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore 639798, Singapore

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